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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

MONA M. EISSA

Serial No. 10/621,879 (TI-28394.1)

Filed July 17, 2003

For: EFFECTIVE SOLUTION AND PROCESS TO WET-ETCH  
METAL-ALLOY FILMS I SEMICONDUCTOR PROCESSING

Art Unit 1765

Examiner Kin-Chan Chen

Customer No. 23494

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8**

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2-27-06

  
Jay M. Cantor, Reg. No. 19,906

**AMENDMENT UNDER 37 C.F.R. 1.116**

In response to the Office action dated February 7, 2006, please amend the above-identified application as follows: